



IN THE
UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Amnon Silverstein

Serial No.:

Examiner:

Filing Date: March 27, 2001

Group Art Unit:

Title: Single Sensor Chip Digital Stereo Camera

COMMISSIONER FOR PATENTS
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement is submitted:

- (X) under 37 CFR 1.97(b), or
(Within three months of filing national application; or date of entry of national application; or before mailing date of first office action on the merits; whichever occurs last)
- () under 37 CFR 1.97(c) together with either a:
() Statement under 37 CFR 1.97(e), or
() a \$240.00 fee under 37 CFR 1.17(p), or
(After the CFR 1.97 (b) time period, but before final action or notice of allowance, whichever occurs first)
- () under 37 CFR 1.97 (d) together with a:
() Statement under 37 CFR 1.97(e), and
() a petition under 37 CFR 1.97(d)(2), and
() a \$130.00 petition fee set forth in 37 CFR 1.17(i).
(Filed after final action or notice of allowance, whichever occurs first, but before payment of the issue fee)

Please charge to Deposit Account 08-2025 the sum of \$0.00. At any time during the pendency of this application, please charge any fees required or credit any overpayment to Deposit Account 08-2025 pursuant to 37 CFR 1.25.

(X) Applicant(s) submit herewith Form PTO 1449 - Information Disclosure Citation together with copies, of patents, publications or other information of which applicant(s) are aware, which applicant(s) believe(s) may be material to the examination of this application and for which there may be a duty to disclose in accordance with 37 CFR 1.56.

() A concise explanation of the relevance of foreign language patents, foreign language publications and other foreign language information listed on PTO Form 1449, as presently understood by the individuals(s) designated in 37 CFR 1.56 (c) most knowledgeable about the content is given on the attached sheet, or where a foreign language patent is cited in a search report or other action by a foreign patent office in a counterpart foreign application, an English language version of the search report or action which indicates the degree of relevance found by the foreign office is listed on form PTO 1449 and is enclosed herewith.

It is requested that the information disclosed herein be made of record in this application.

"Express Mail" label no. EK916903731US

Date of Deposit March 27, 2001

I hereby certify that this is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and is addressed to: Commissioner for Patents, Washington, D.C. 20231.

By

Typed Name: D. James Chung

Respectfully submitted,

Amnon Silverstein

By

D. J. Chung

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Sb/ln

FORM PTO-1449

LIST OF PATENTS AND PUBLICATIONS FOR
APPLICANT'S INFORMATION DISCLOSURE
STATEMENT

(Use several sheets if necessary)

ATTY. DOCKET NO.

10992483

SERIAL NO.

APPLICANT

Amnon Silverstein

FILING DATE

March 27, 2001

GROUP

10971 U.S. PTO

09/818922



REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
	1A	4,523,809	Jun. 18, 1985	Taboada et al.		
	1B	5,541,642	Jul. 30, 1996	Ashbey		
	1C	5,790,086	Aug 4, 1998	Zelitt		
	1D	5,832,325	Nov. 3, 1998	Ito et al.		
	1E	6,044,232	Mar. 28, 2000	Pan		
	1F	6,128,132	Oct. 3, 2000	Wieland et al.		
	1G	6,195,150	Feb. 27, 2001	Silverbrook		
	1H					
	1I					
	1J					
	1K					

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	TRANSLATION	
							YES	NO
	1L							
	1M							
	1N							
	1O							
	1P							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

1Q	Edward H. Adelson and John Y. A. Wang, Single Lens Stereo with a Plenoptic Camera, IEEE Transactions on Pattern Analysis and Machine Intelligence, Vol. 14, No. 2, February 1992
1R	P. von Ballmoos et al., Crystal Diffraction Telescopes for Nuclear Astrophysics
1S	Kam Y. Lau and Richard S. Muller, Adaptive Micromechanical Technologies for Optoelectronics Modules and Systems, Semiannual Report January- June 1998, DARPA Project Number: DABT63-95-C-0055

EXAMINER

DATE CONSIDERED